(Substitute) PTO/SB/21 (09-04) Approved for use through 07/31/2006. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE NOV 0 1 2005 er the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/536,674 TRANSMITTAL Filing Date July 29, 2005 First Named Inventor **FORM** Torsten MULLER Art Unit 1651 **Examiner Name** (to be used for all correspondence after initial filing) Attorney Docket Number B1180/20038 Total Number of Pages in This Submission foreign patent documents and 6 non-patent literature docs. **ENCLOSURES** (Check all that apply) After Allowance Communication to TC Fee Transmittal Form Drawing(s) Appeal Communication to Board Licensing-related Papers Fee Attached of Appeals and Interferences Appeal Communication to TC Petition Amendment/Reply (Appeal Notice, Brief, Reply Brief) Petition to Convert to a Proprietary Information After Final **Provisional Application** Power of Attorney, Revocation Affidavits/declaration(s) Status Letter Change of Correspondence Address Other Enclosure(s) (please Identify **Terminal Disclaimer** Extension of Time Request below): Return Receipt Postcard, Form PTO Request for Refund Express Abandonment Request 1449/A, 4 foreign patent documents and 6 CD, Number of CD(s) non-patent literature documents Information Disclosure Statement Landscape Table on CD Certified Copy of Priority Remarks Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts

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Signature				
Typed or pr	rinted name David M. Tener	Date	October 26, 2005	

ensure consideration of this submission. SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT EXAMINING OPERATION

Applicant(s): Torsten MÜLLER et al.

Serial No: 10/536,674

Group Art Unit: 1651

Filed: July 29, 2005

Examiner:

Att. Docket No.: B1180/20038

Confirmation No.: 9821

For:

FLUIDIC MICROSYSTEM COMPRISING FIELD-FORMING PASSIVATION

LAYERS PROVIDED ON MICROELECTRODES

## **INFORMATION DISCLOSURE STATEMENT**

Mail Stop AMENDMENTS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. No copies of U.S. patents or U.S. patent application publications are attached. 37 CFR § 1.98(a)(2)(ii). It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. No representation is made that the reference(s) is/are prior art with respect to this application.

This Information Disclosure Statement is being filed within three months of the filing date of a national application other than a CPA under 37 CFR § 1.53(d), within three months of the date of entry of the national stage as set forth in 37 CFR § 1.491 in an international application, before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of an RCE under 37 CFR § 1.114. No certification or fee is required. 37 CFR § 1.97(b).

Application No. 10/536,674 IDS dated October 26, 2005

U.S. Patent Application No. 6,749,736 B1 is an English-language counterpart of DE 198 60 117 and DE 198 60 118. U.S. Patent Application No. 6,727,451 B1 is an English-language counterpart of DE 198 15 882.

Respectfully submitted,

CAESAR, RIVISE, BERNSTEIN, COHEN & POKOTILOW, LTD.

October 26, 2005

Please charge or credit our Account No. 03-0075 as necessary to effect entry and/or ensure consideration of this submission.

David M. Tener

 $By_{\underline{}}$ 

Registration No. 37,059 Customer No. 03000

(215) 567-2010

Attorneys for Applicant(s)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Compl	ete if Known	
Application Number	10/536,674	
Filing Date	July 29, 2005	
First Named Inventor	Torsten MÜLLER	
Group Art Unit	1651	
Examiner Name		
Attorney Docket Number	B1180/20038	

Sheet of

**U.S. PATENT DOCUMENTS** 

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		Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	of Cited Document MM-DD-YYYY	
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		6,749,736	B1	FUHR et al.	06-15-2004	

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OTHER DOCUMENTS - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
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DATE CONSIDERED **EXAMINER** 

<sup>\*</sup>Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.